



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akira SATO

Group Art Unit: 2825

Application No.: 09/424,500

Examiner: G. Lee, Jr.

Filed: February 22, 2000

Docket No.: 104788

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, MOLDING DEVICE FOR SEMICONDUCTOR DEVICE, AND SEMICONDUCTOR DEVICE

REQUEST FOR RECONSIDERATION

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

In reply to the Office Action dated August 28, 2001, the period for reply being extended by the attached Petition for Extension of Time, reconsideration of the above-identified application is respectfully requested.

Claims 1-30 are pending. Reconsideration in view of the following remarks is respectfully requested.

I. THE SPECIFICATION SATISFIES ALL FORMALITIES

The Office Action objects to the specification for not disclosing the items #52 and #84, which are depicted in the drawings. This objection is respectfully traversed.

Applicant respectfully submits that item 52 of Figures 1, 6, 7 and 8 are disclosed in page 9, lines 13-15. Item 52 coupled with an arrow is used to show the rotation space of a front cam of the present invention.